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PATENT
jc551 U.S. PTO
09/177814
10/23/98

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Terry L. Gilton

Serial No.: Not yet assigned

Filed: October 23, 1998

For: SEPARATION APPARATUS
INCLUDING POROUS SILICON COLUMN

Examiner: Unknown

Group Art Unit: Unknown

Attorney Docket No.: 3530US (97-1257)

NOTICE OF EXPRESS MAILING

Express Mail Mailing Label Number:
EL206385888US

Date of Deposit with USPS: October 23, 1998

Person making Deposit: Jared Turner

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In compliance with the duty to disclose information material to patentability pursuant to 37 C.F.R. § 1.56, it is respectfully requested that this Information Disclosure Statement be entered and the documents listed on attached Form PTO-1449 be considered by the Examiner and made of record. Copies of the listed documents are enclosed pursuant to 37 C.F.R. § 1.98(a).

In accordance with 37 C.F.R. § 1.97(g) and (h), filing of this Information Disclosure Statement is not to be construed as a representation that a search has been made or an admission that the information cited herein is, or is considered to be, material to patentability

as defined in 37 C.F.R. § 1.56(b). Further, no representation is made by Applicant herein that no other possible material information as defined in 37 C.F.R. § 1.56(b) exists.

DOCUMENTS

U.S. Patent Documents

<u>U.S. Patent No.</u>	<u>Issue Date</u>	<u>Inventor</u>
4,471,647	September 18, 1984	Jerman et al.
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4,869,282	September 26, 1989	Sittler et al.
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5,248,614	September 28, 1993	Wang
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5,360,759	November 1, 1994	Stengl et al.
5,421,958	June 6, 1995	Fathauer et al.
5,427,648	June 27, 1995	Pamulapati et al.
5,501,787	March 26, 1996	Bassous et al.
5,508,542	April 16, 1996	Geiss et al.
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5,583,281	December 10, 1996	Yu
5,599,759	February 4, 1997	Inagaki et al.
5,663,488	September 2, 1997	Wang et al.

Other Documents

Stephen C. Terry et al., "A GAS CHROMATOGRAPHIC AIR ANALYZER FABRICATED ON A SILICON WAFER", IEEE Transactions on Electron Devices, Vol. ED-26, No. 12, December 1979, pps. 1880-1886.

Applicant offers to supply any explanation or discussion of the documents which the Examiner feels is necessary or desirable and which is requested.

This Information Disclosure Statement is filed within three (3) months of the filing date of the above-identified application, and no certification pursuant to 37 C.F.R. § 1.97(c) or a fee pursuant to 37 C.F.R. 1.17(p) is required.

Respectfully submitted,



Brick G. Power
Registration No. 38,581
Attorney for Applicant
TRASK, BRITT & ROSSA
P. O. Box 2550
Salt Lake City, Utah 84110-2550
Telephone: (801) 532-1922

Date: October 23, 1998

BGP/dj

Enclosures: Form PTO-1449
Copy of documents cited